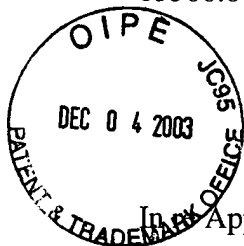


03500.013314.2

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of:

TOSHIKAZU ONISHI ET AL.

Application No.: 10/014,131

Filed: December 13, 2001

For: METHOD FOR MANUFACTURING )  
ELECTRON EMISSION ELEMENT, :  
ELECTRON SOURCE, AND IMAGE )  
FORMING APPARATUS :

Examiner: K. Ramsey

Group Art Unit: 2879

December 1, 2003

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Preliminary to continued examination, please amend the above-identified application as follows, the claims changes being reflected in the listing that begins at page 2, and the Remarks beginning at page 6.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

December 1, 2003.

(Date of Deposit)

LEONARD P. DIANA (Reg No. 29,296)

(Name of Attorney for Applicants)

Signature

December 1, 2003

Date of Signature